

Application/Control No.	Applicant(s)/Patent under Reexamination
10/790,720	WU ET AL.
Examiner	Art Unit
Shin-Lin Chen	1632

					
SEARCHED					
Class	Subclass	Date	Examiner		
800	4				
800	13				
800	17				
800	21				
800	22				
800	25				
435	320.1				
536	23.5	3/13/2006	4v		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
800	4			
800	13			
800	17			
800/21, 22, 25, 435/320.1, 536/23.5, AU interference search		3/13/2006	Gu	

SEARCH N (INCLUDING SEARC	OTES H STRATEGY	()
	DATE	EXMR
Updated.	3/13/2006	w